SEP/M-799

	SFP/M-799 PATENT	,
1	TRENCH DMOS POWER TRANSISTOR WITH FIELD-SHAPING BODY PROFILE AND THREE-DIMENSIONAL GEOMETRY	
2	FIELD-SHAPING BODY PROFILE AND	
3	THREE-DIMENSIONAL GEOMETRY	
4		-
5	Constantin Bulucea	
6	Rebecca Rossen	
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8	ABSTRACT	
9	Power MOSFET apparatus, and method for its production,	
10	that suppresses voltage breakdown near the gate, using a	
11	polygon-shaped trench in which the gate is positioned, using	
12	a shaped deep body junction that partly lies below the	
13	trench bottom, and using special procedures for growth of	
14	gate oxide at various trench corners.	
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